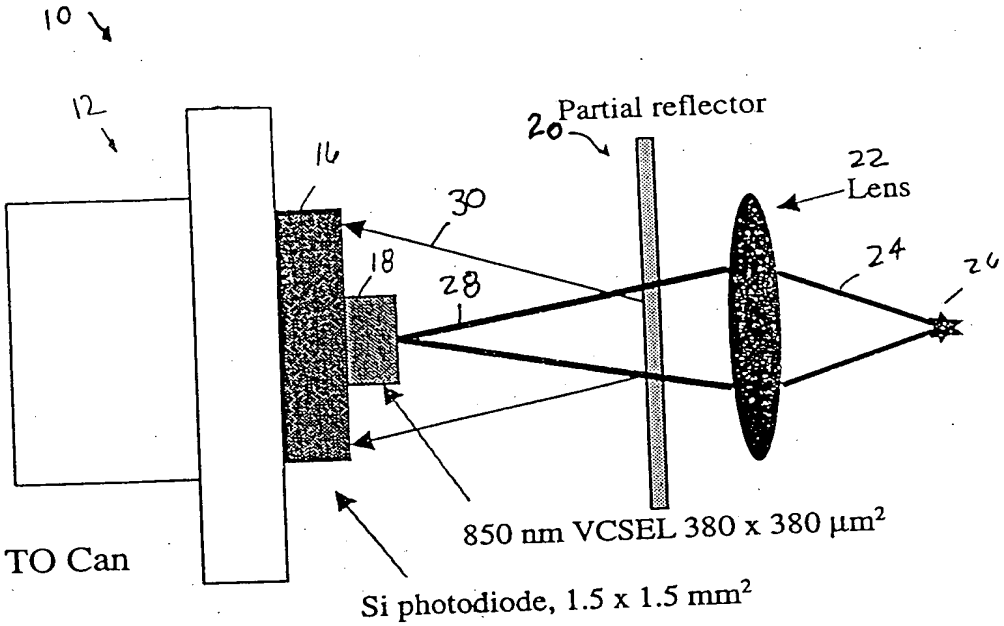

FIG. 1
PRIOR ART

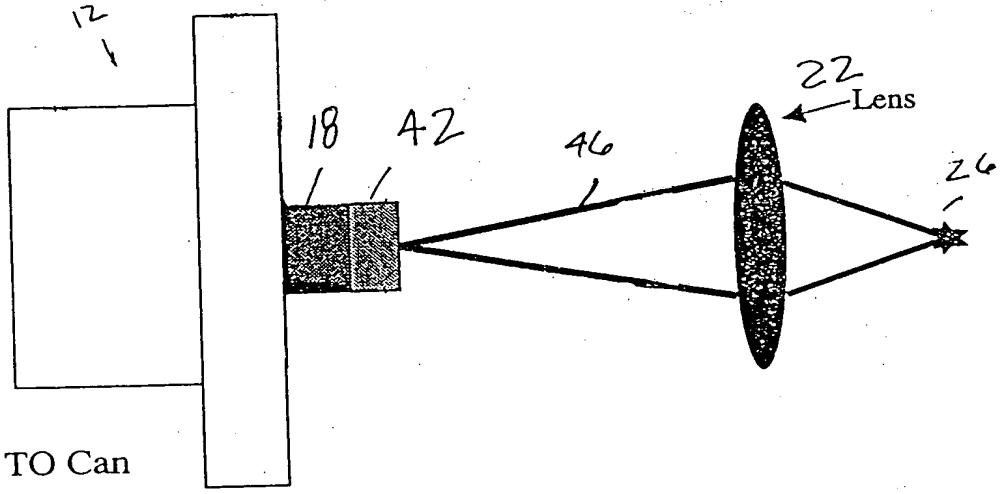

FIG. 2

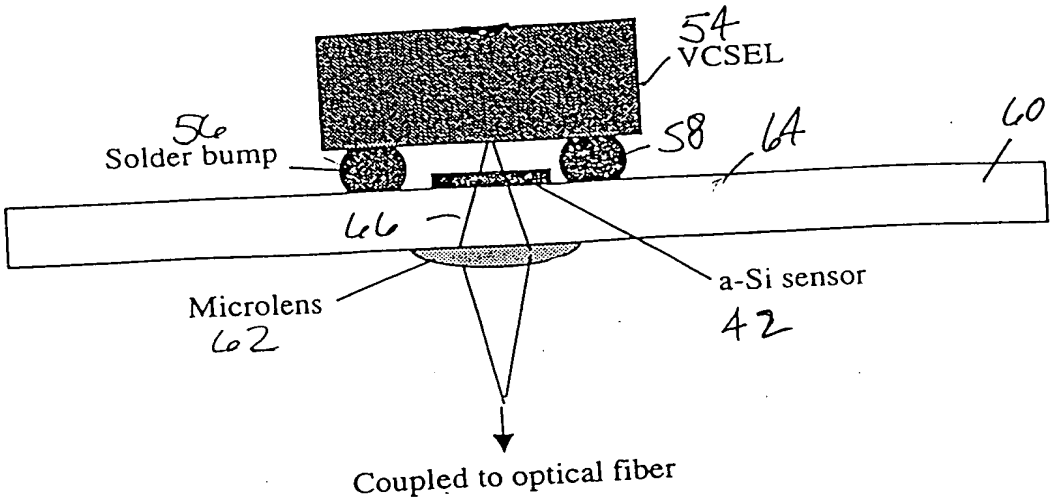

FIG. 3

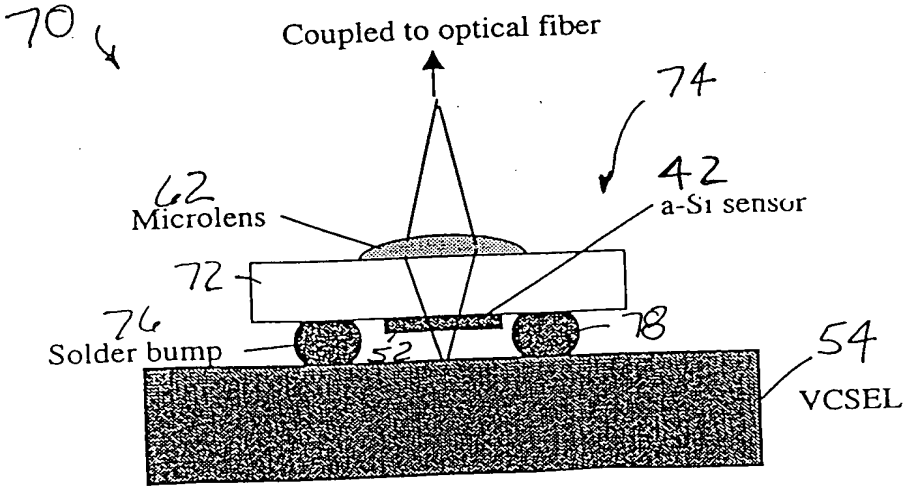

FIG. 4

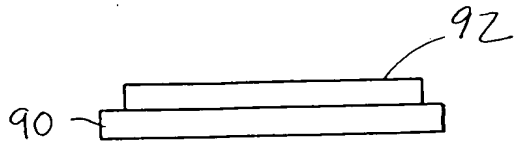

FIG. 5a A

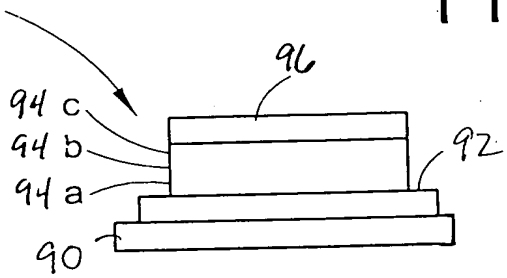

FIG. 5b B

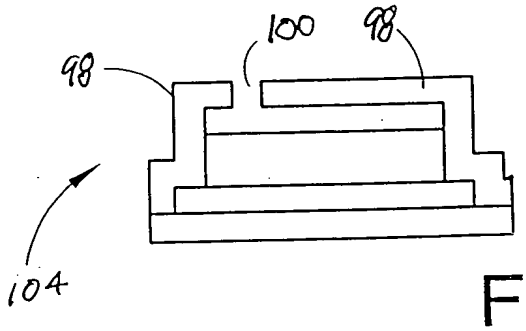

FIG. 5c C

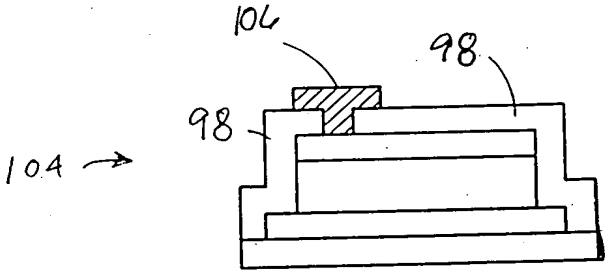

FIG. 5d D

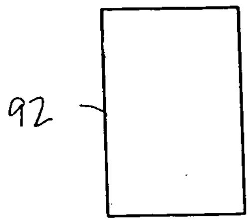

FIG. 6A

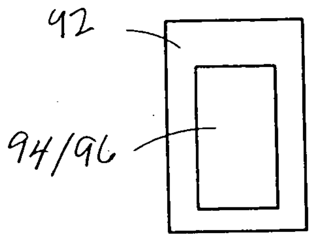

FIG. 6B

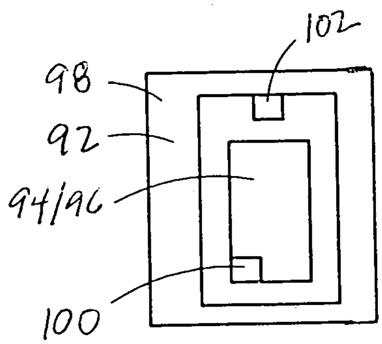

FIG. 6C

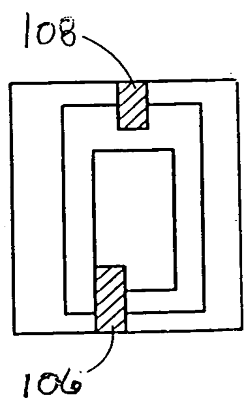

FIG. 6D

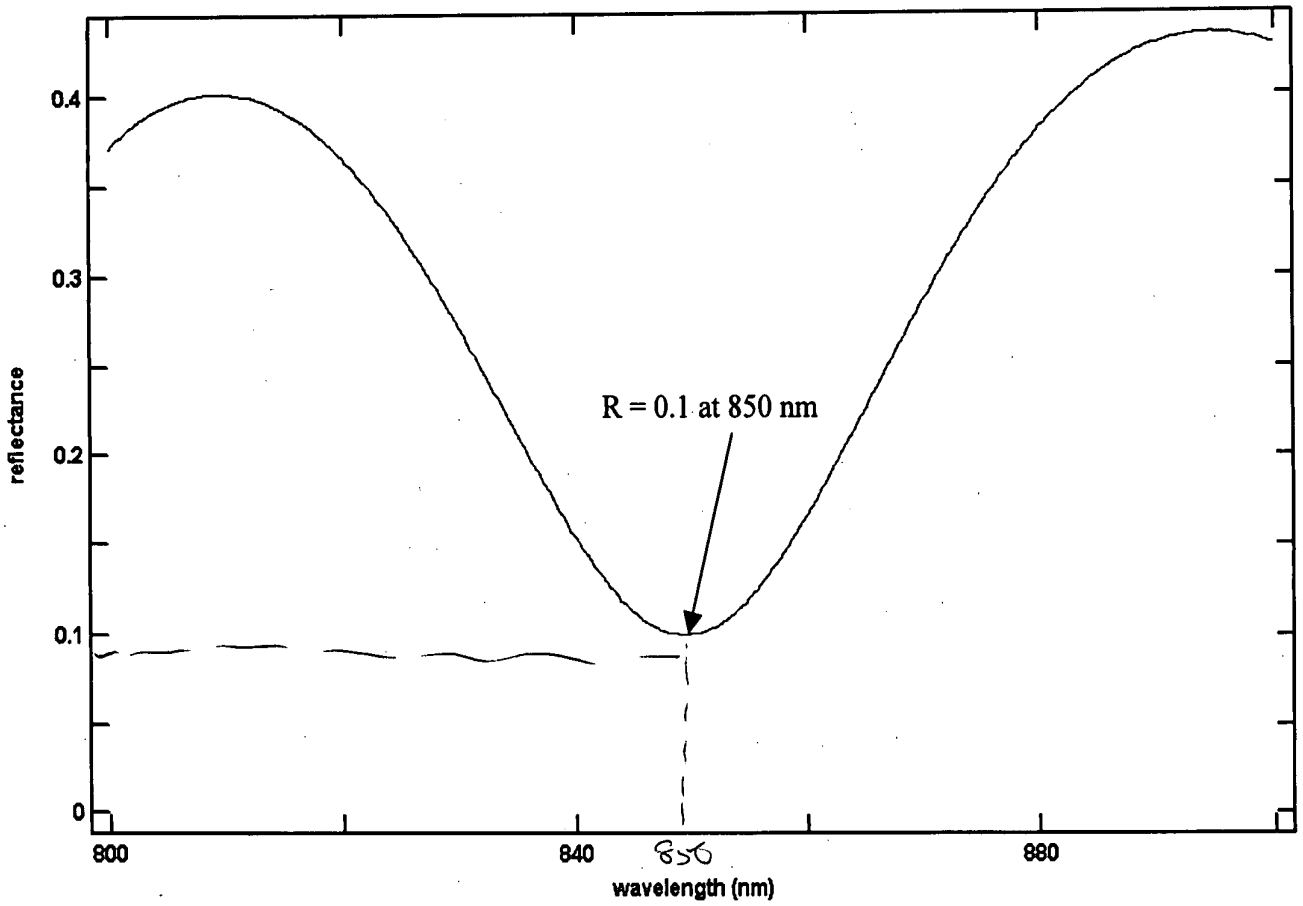

Figure 7

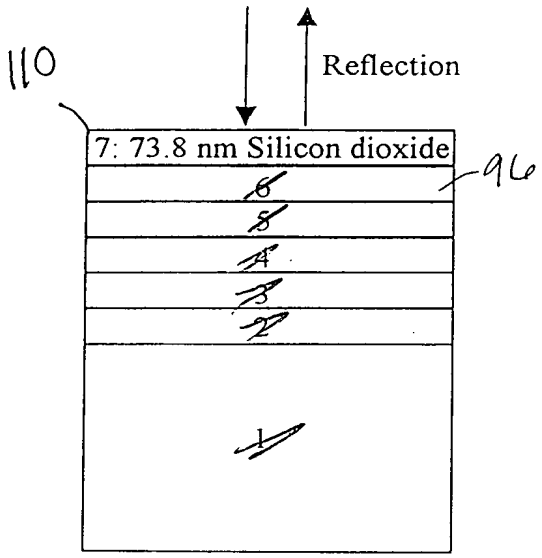

FIG. 8

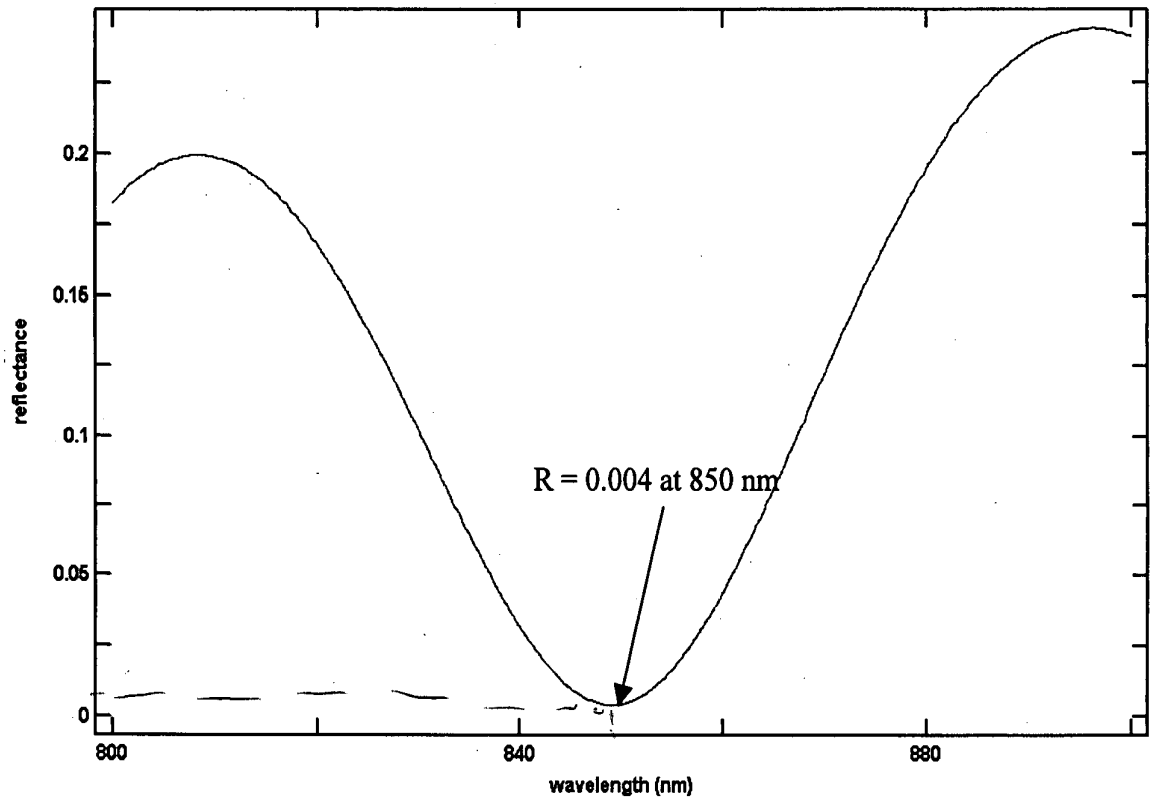

Figure 9

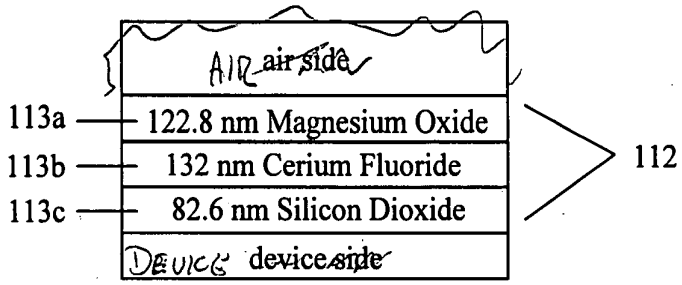

Figure 10

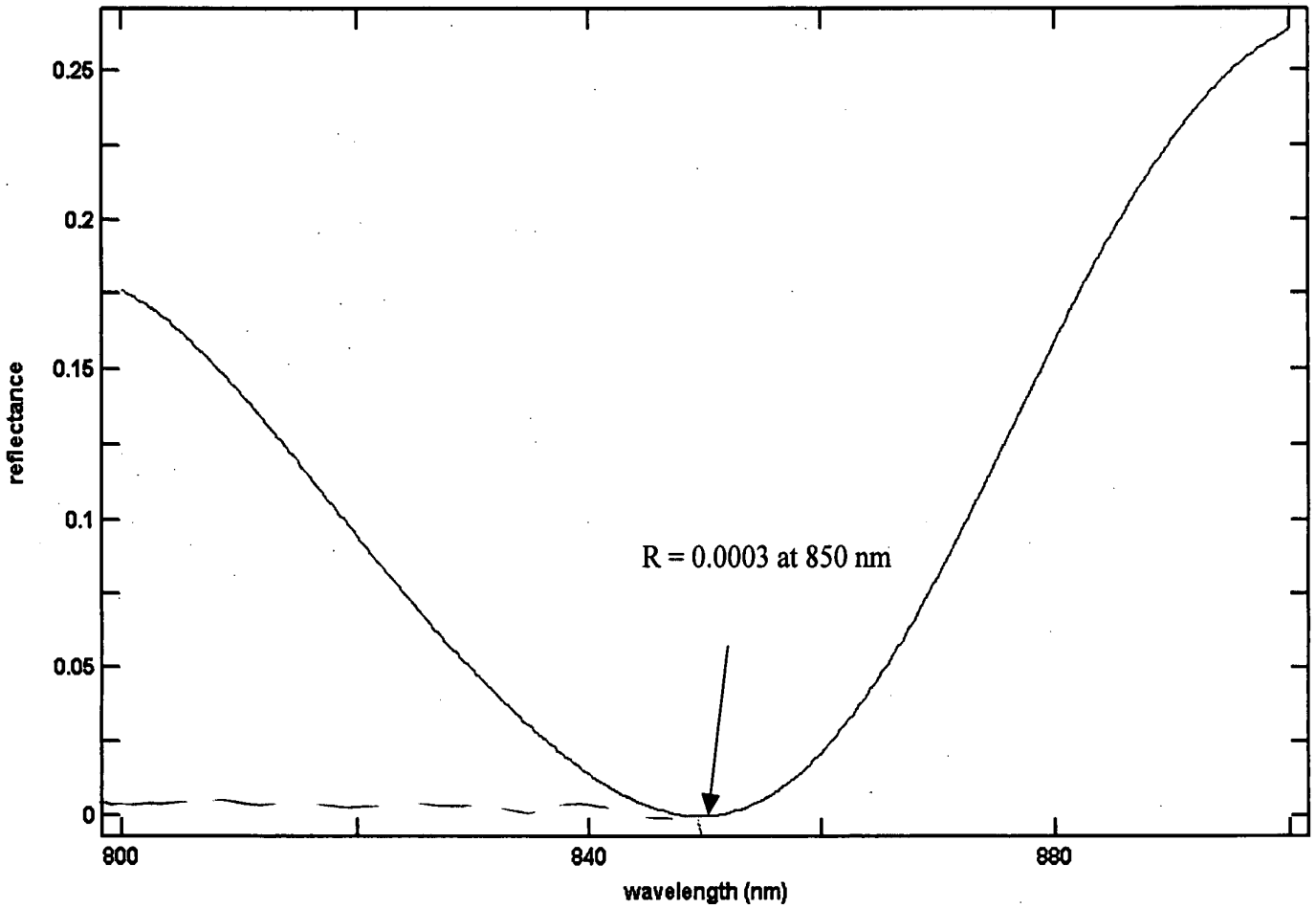

Figure 11

	Air	
	SiO_2	(225.2 nm)
	TiO_2	(93.5 nm)
96	ITO	(20 nm)
94	Si	(707.7 nm)
92	ITO	(10 nm)
	TiO_2	(87.2 nm)
	glass substrate	

12A

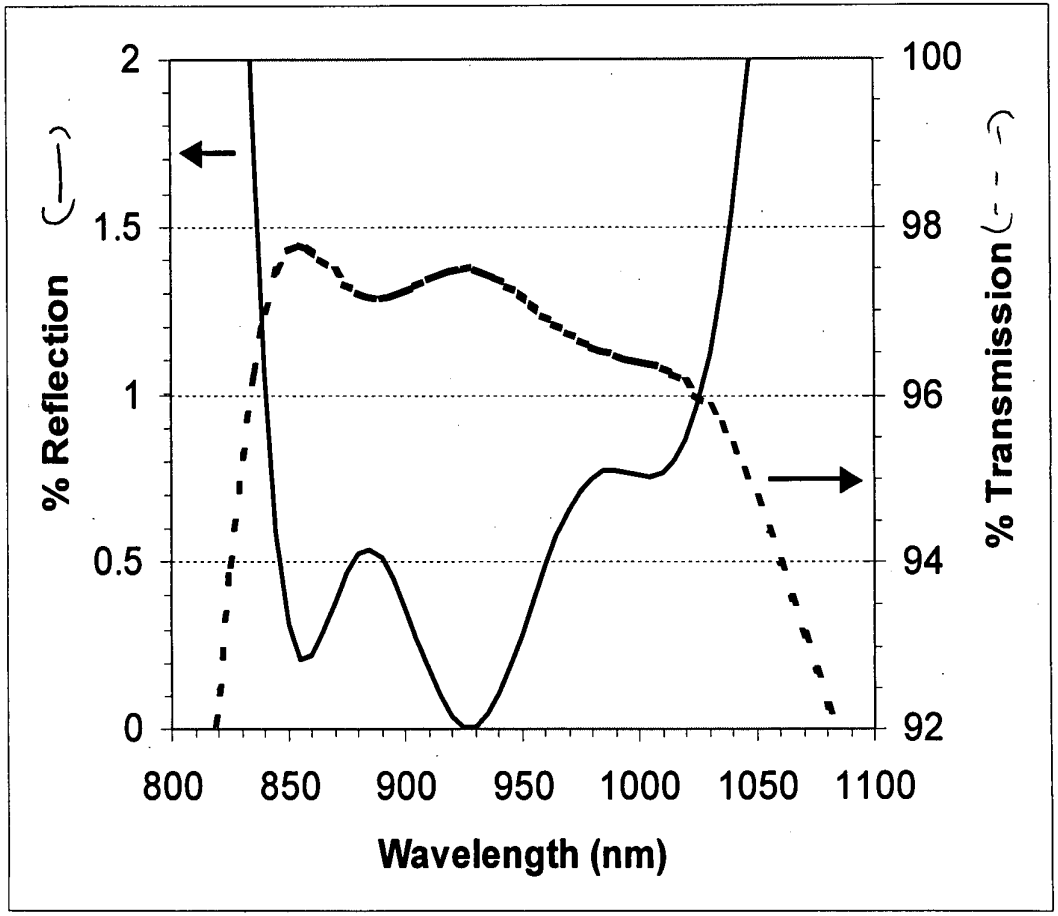

Figure 12B

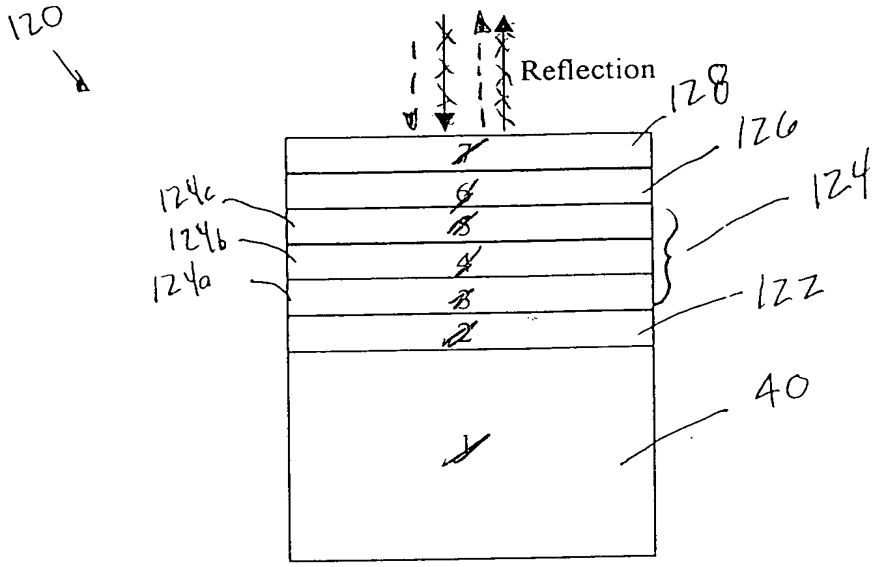

FIG. 13

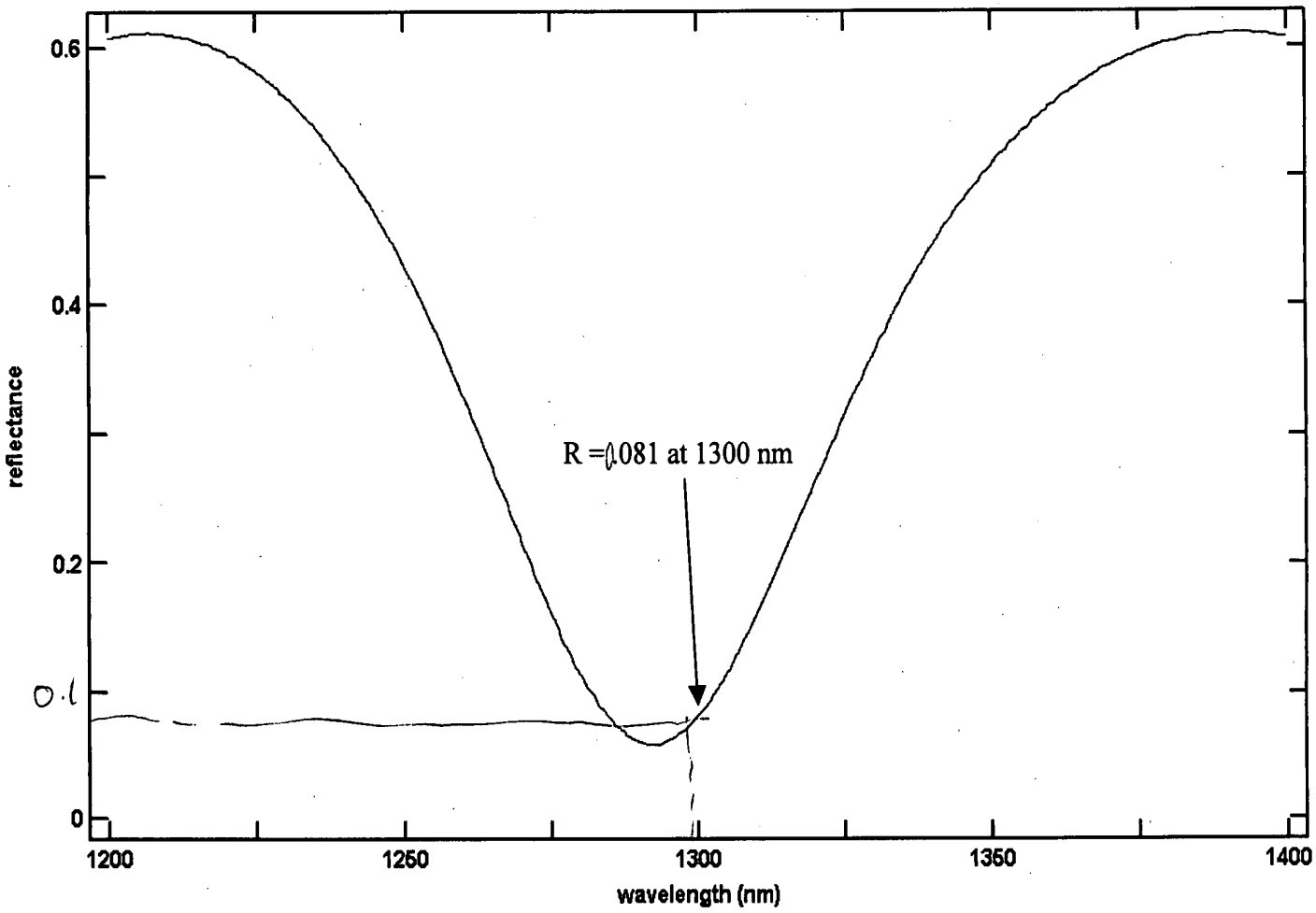

Figure 14

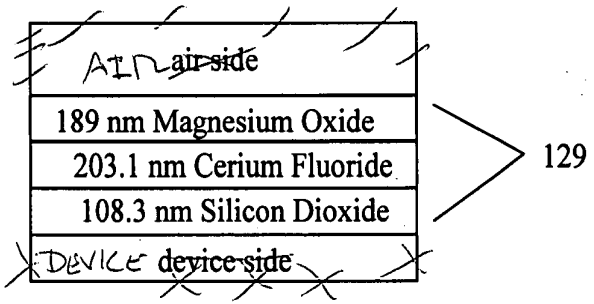

Figure 15

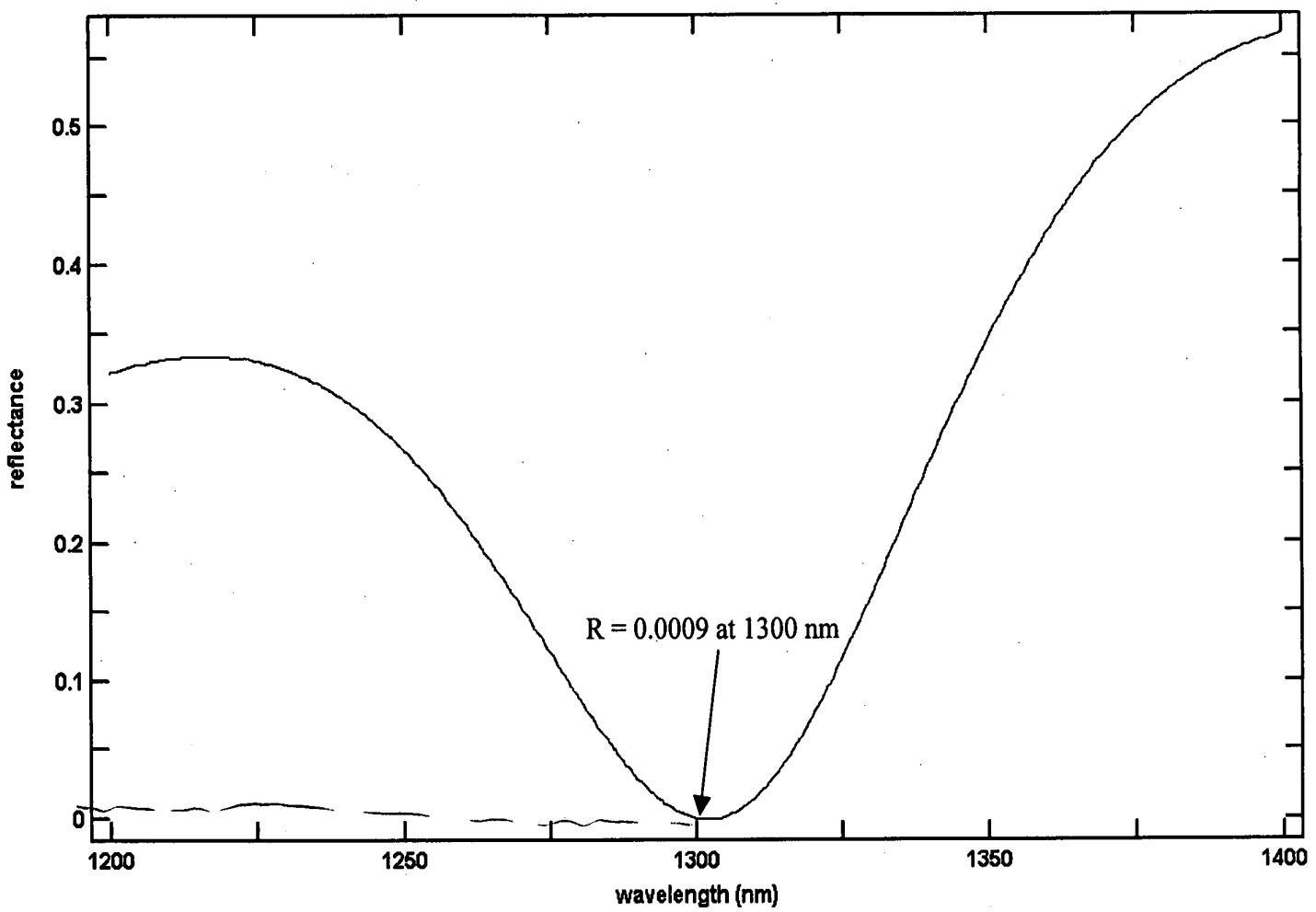

Figure 16

	Air		
	SiO_2	274.6	nm
	Si	68.1	nm
96	ITO	20	nm
94	Si	663	nm
92	ITO	10	nm
	Si	141.8	nm
	SiO_2	86.68	nm
	Si	35.48	nm
	glass substrate		

17A

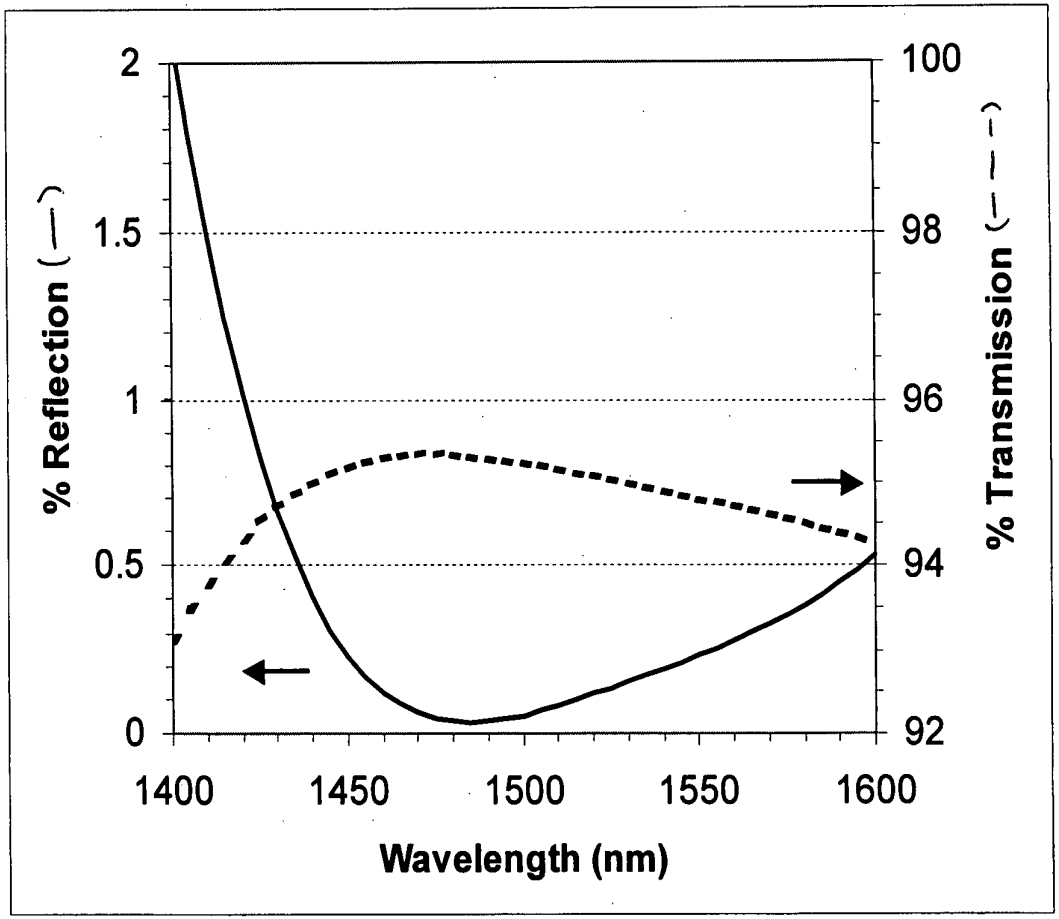

Figure 17B

	Air		
	SiO_2	(154.8	nm)
	TiO_2	(102.3	nm)
96	ITO	(20	nm)
94	Si	(601.5	nm)
92	ITO	(10	nm)
	TiO_2	(158.1	nm)
	glass substrate		

18A

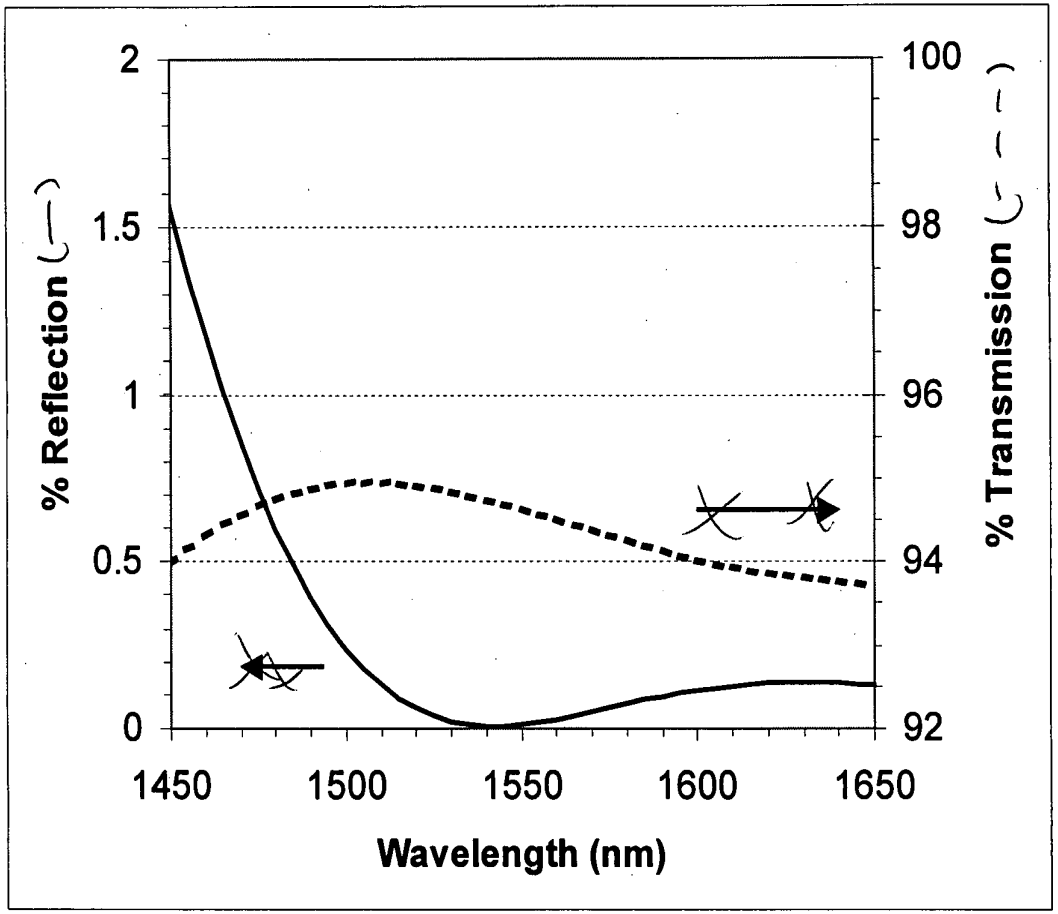

Figure 18B

	Air		
	SiO_2	181.2	nm
	TiO_2	106.9	nm
96	ITO	10	nm
94	Si	569	nm
92	ITO	5	nm
	TiO_2	158.3	nm
	glass substrate		

19A

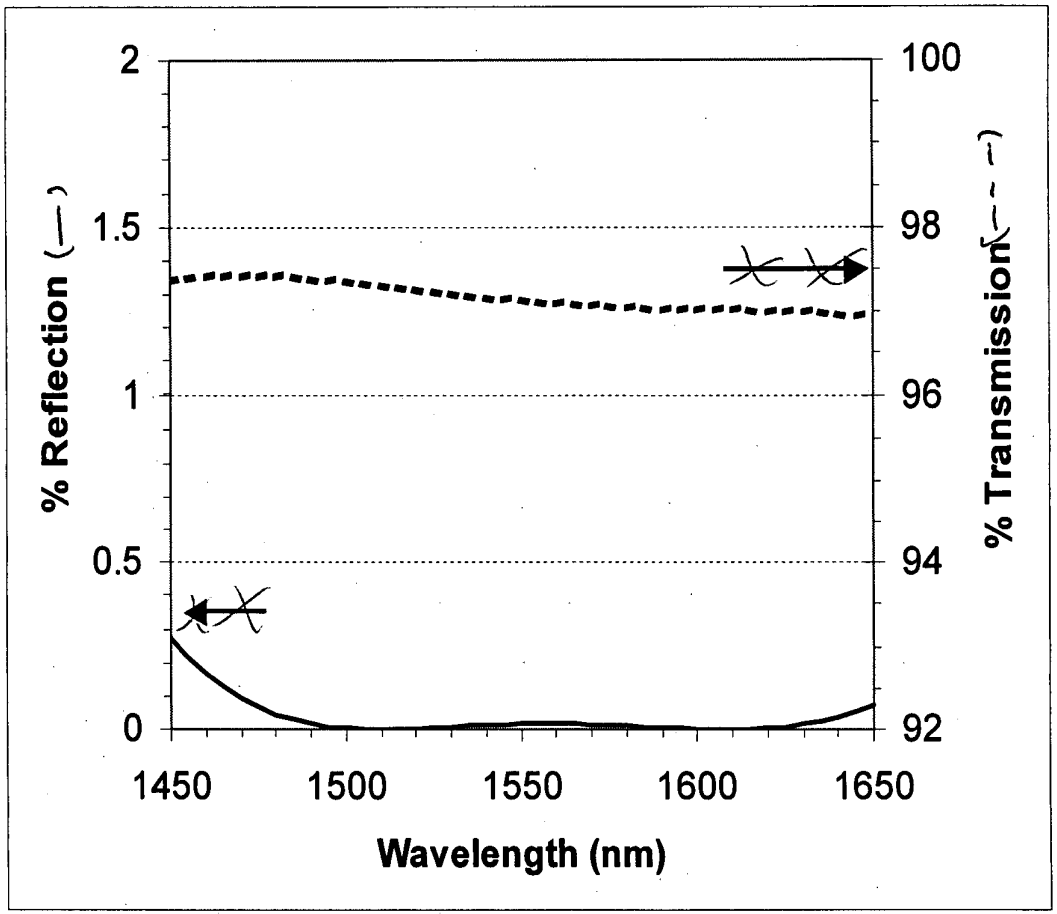

Figure 19B

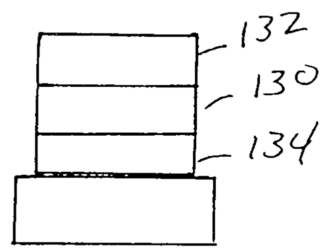

FIG. 20

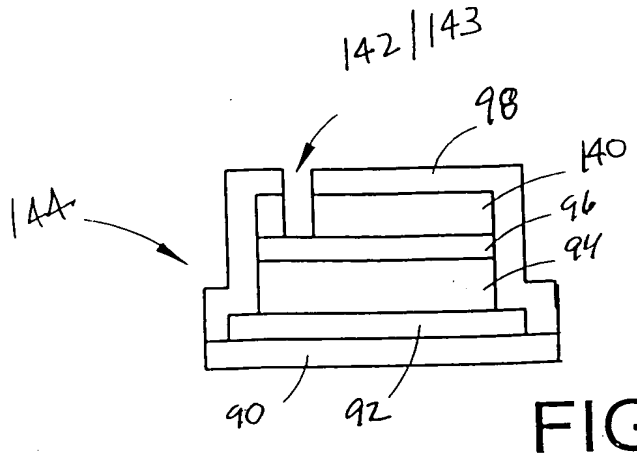

FIG. 21 ~~a~~ A

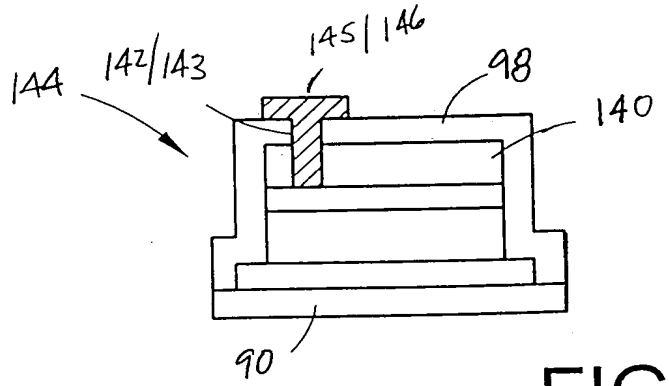

FIG. 21 ~~b~~ B

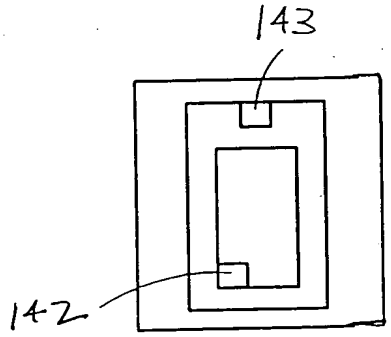

FIG. 22 ~~a~~ A

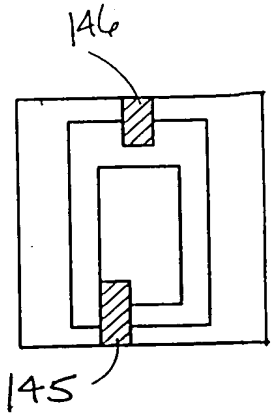

FIG. 22 ~~b~~ B

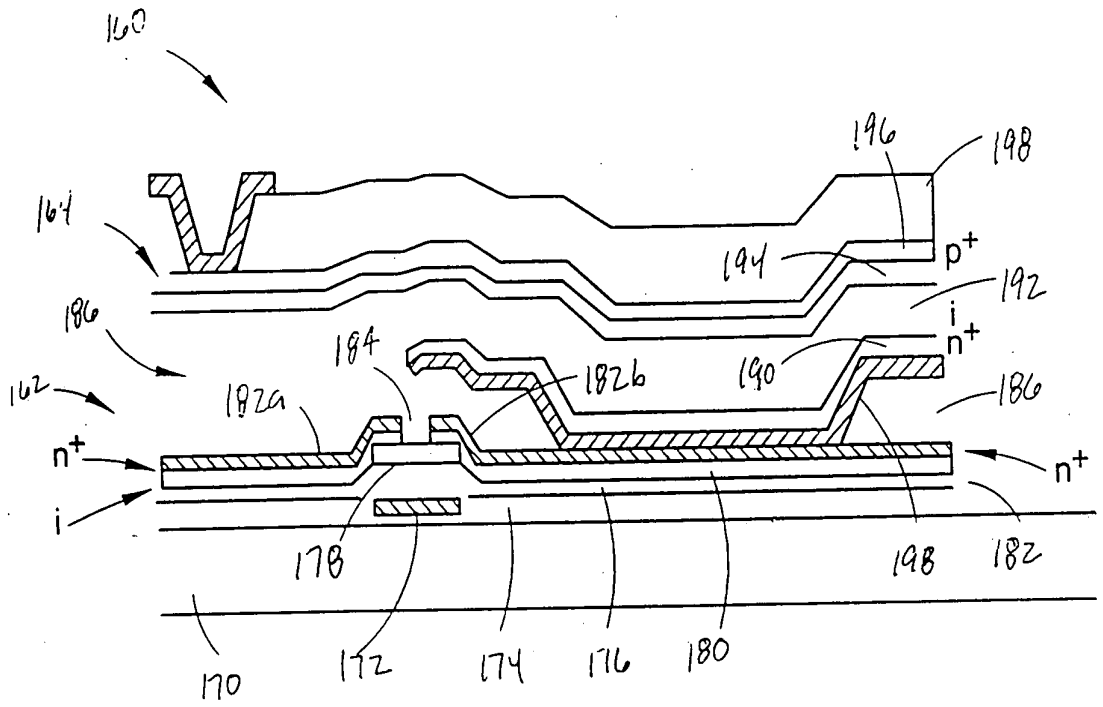

FIG. 23

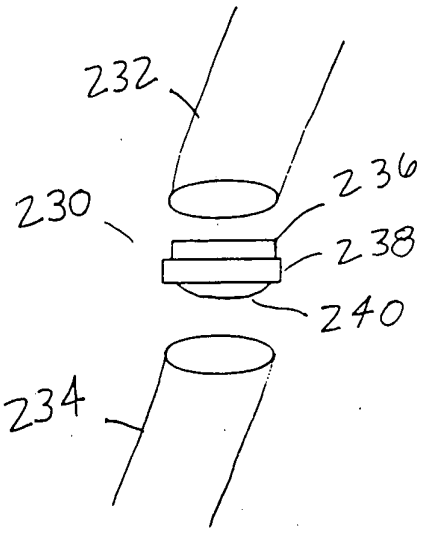

FIG. 27

FIG. 24

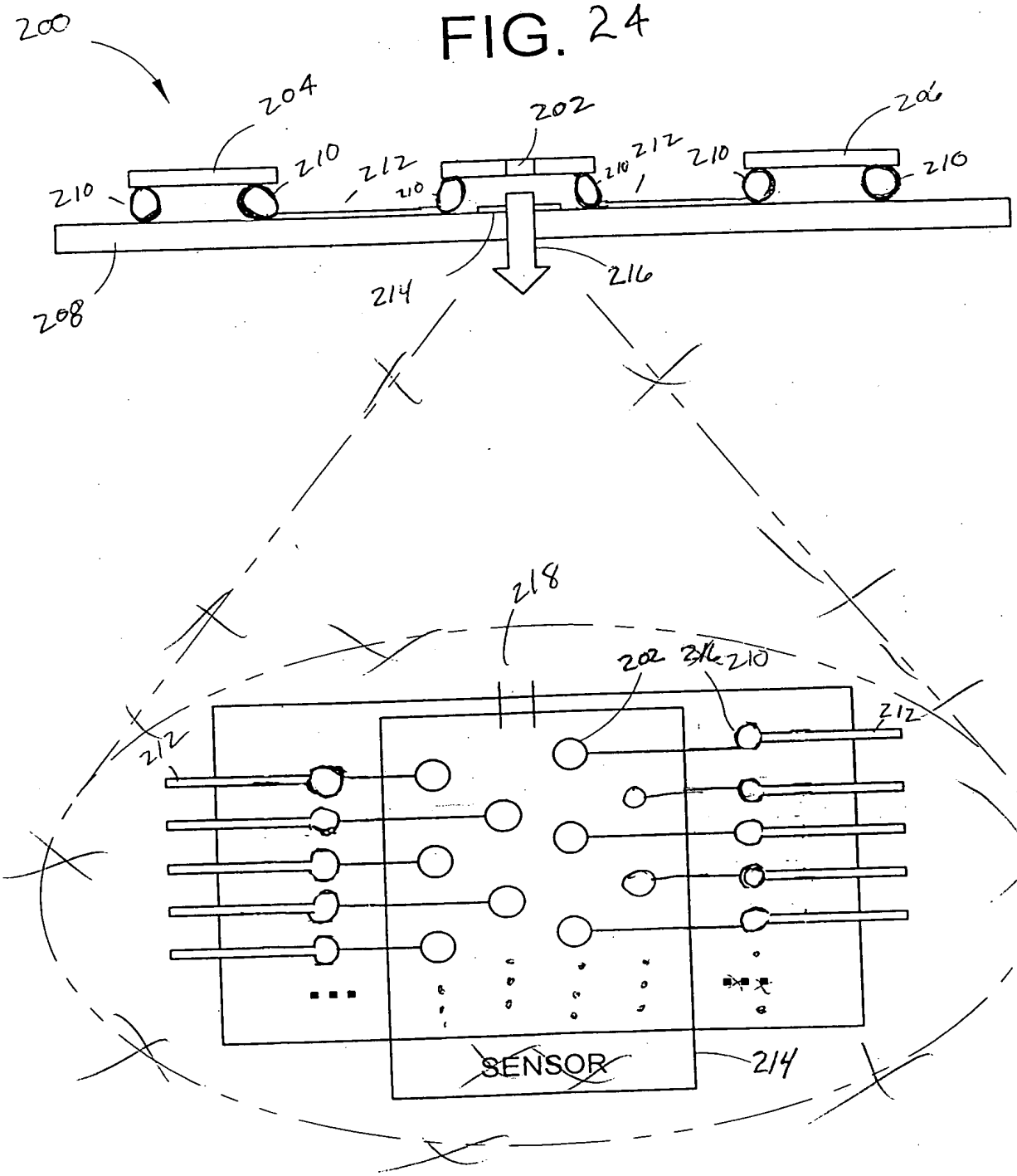

FIG. 25

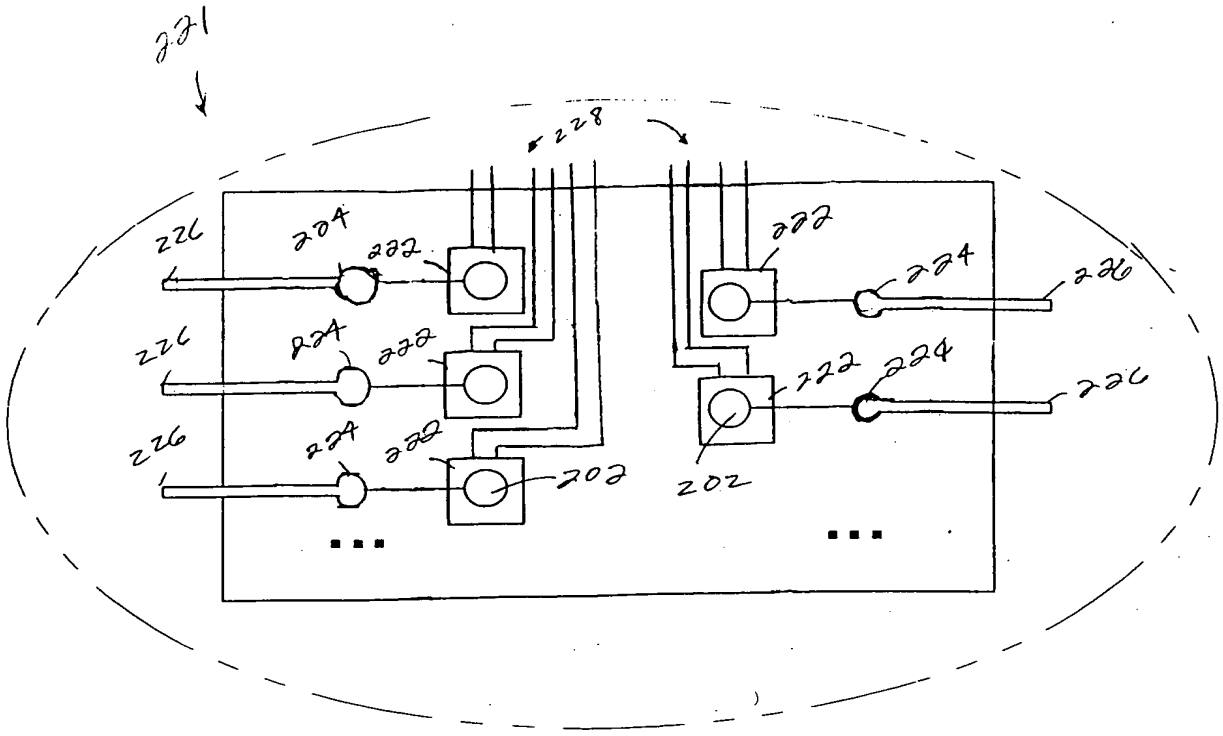

FIG. 26